

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT Application of
Yasuhiko TAKEMURA et al.

Serial No. 09/321,715

Filed: May 28, 1999

For: SEMICONDUCTOR DEVICE AND)

PROCESS FOR FABRICATING)

THE SAME



Art Unit: 2822

) Examiner: M. Wilczewski

) Date: March 12, 2001

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PRELIMINARY AMENDMENT

Honorable Assistant Commissioner for Patents

Washington, D.C. 20231

Sir:

Please preliminarily amend the subject application as follows:

IN THE CLAIMS:

Please amend claims 1, 9, 17, 25, 33, 41, 49, 56, 63, 70, 78, and 86 as follows below. Please note that these amended claims are presented below in their amended form. They are further presented as an Attachment to the Amendment whereby the amendments to the claims are outlined using the conventional method of bracketing and underlining.

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1. (Amended) A method of manufacturing a display device having a plurality of thin film transistors, comprising the steps of:
- forming a semiconductor film comprising silicon over a glass substrate;
 - crystallizing said semiconductor film; and

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